

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	: Shinji Maekawa	Art Unit	: 2813
Serial No.	: 09/724,403	Examiner	: Stephen W. Smoot
Filed	: November 27, 2000	Confirmation No.:	7575
		Notice of Allowance Date: February 14, 2007	
Title	: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE THAT INCLUDES FORMING A MATERIAL WITH A HIGH TENSILE STRESS IN CONTACT WITH A SEMICONDUCTOR FILM TO GETTER IMPURITIES FROM THE SEMICONDUCTOR FILM (AS AMENDED)		

MAIL STOP ISSUE FEE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO NOTICE OF ALLOWANCE

In response to the Notice of Allowance mailed February 14, 2007, enclosed are a completed issue fee transmittal form PTOL-85b and a check for \$1400 for the required issue fee and publication fee, including patent copies.

Please apply any additional charges or credits to our Deposit Account No. 06-1050.

Respectfully submitted,

Date:

5/11/07

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